

New XRF Developments Enhancing ENIG and ENEPIG Measurement Throughput and Precision

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What is XRF?

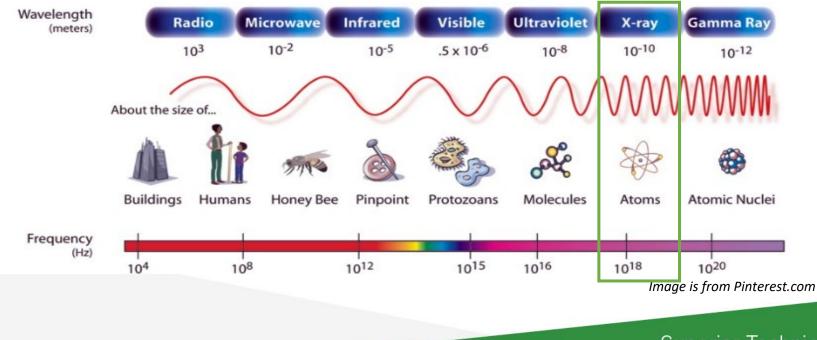
- XRF is a spectroscopic analytical method for measuring elemental composition and plating thickness
- Sensitive to all metallic elements (AI U)
- Can measure thickness from sub-nanometer up to microns of thickness
- Performs thickness & composition simultaneously, up to 5 layers and 25 elements

Image is from Pinterest.com



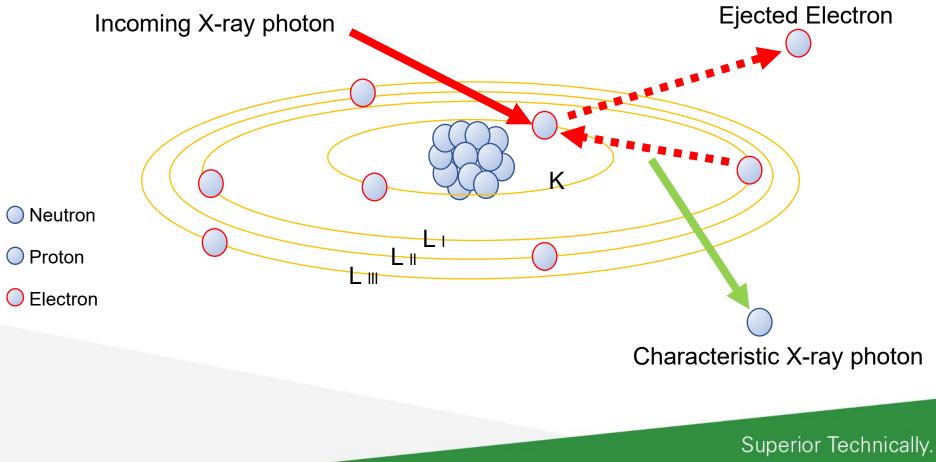
What are X-rays

- A type of radiation that is part of the electromagnetic spectrum
- X-Rays have a wavelength ranging from 0.03 to 3 nanometers





Characteristic Fluorescent Radiation



Supported Locally.



IPC - 4552A Instrument Requirements

• Specifies the use of XRF to verify process and gage capability

 $C_{g} = \frac{0.2 \text{ x T}}{6 \text{ x s}}$ $C_{gk} = \frac{0.1 \text{ x T} - \{\text{difference of labeled value \& mean}\}}{3 \text{ x s}}$

Requirement: $C_g \ge 1.33$ $C_{gk} \ge 1.33$

 New XRF developments enable requirements to be met with shorter measurement time

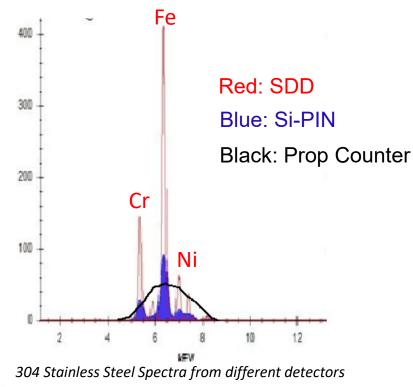


New XRF Developments

- Large Window Silicon Drift Detectors (SDD)
- Polycapillary Optics for focusing x-ray beam
- Choice of Tube Target
- Software Automation
 - Autofocus
 - Pattern Recognition
 - Data Export



Advantage of Solid-State Detector



- Improved signal <u>sensitivity for</u> <u>low Z</u> elements
- Improved <u>detection limits</u> down to nanometer or ppm level
- <u>Better separation</u> of overlapping elements
- Improved <u>stability</u> with minimal drift
- 10+ years life



Large Window Solid State Detector

| Table 1. Meas | uring 2.06μin Αι | ι, 121μin Ni-P | (8%P) standard. |
|---------------|------------------|----------------|-----------------|
|---------------|------------------|----------------|-----------------|

| | SiPin 24mil Collimator | | Large-SDD 24mil Collimator | |
|------------------|---------------------------|-------|-------------------------------|-------|
| Element | Au | Ni-P | Au | Ni-P |
| Average (µin) | 2.08 | 120 | 2.06 | 121 |
| Std Dev | 0.023 | 0.458 | 0.014 | 0.268 |
| Cg | 3.44 | 8.60 | 5.67 | 14.7 |
| C_{gk} | 3.10 | 8.00 | 5.56 | 14.4 |

- SDD offers highest count rates and resolution
 - >50% higher than SiPin
- Lowest baseline noise
- Light element capability (i.e. P, Si, Al)
- Best for finishes <1 µm, complex films such as ENIG, EPIG, ENEPIG



Polycapillary Optics

- Sub-million to multi-million capillary channels
- X-ray passing through each channel is aligned to a high intensity point
- Perfect for very small features, down to 7.5µm spot size
- High flux density gain 100x higher than a pinhole collimator
- Improve precision of readings with shorter time.

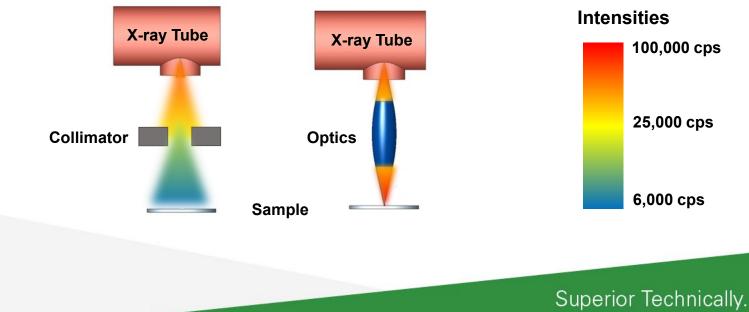
| | 80µm Optics, | | 15µm Optics | |
|-----------------|--------------|-------|-------------|-------|
| Element | Au | Ni-P | Au | Ni-P |
| Average (µin) | 2.06 | 121 | 2.05 | 121 |
| Std Dev | 0.015 | 0.155 | 0.010 | 0.107 |
| Cg | 5.27 | 25.5 | 7.51 | 36.7 |
| C _{gk} | 5.17 | 24.8 | 7.28 | 35.9 |

Table 2. Measuring 2.06µin Au, 121µin Ni-P (8%P) standard.



Polycapillary optics reduce the inverse square loss

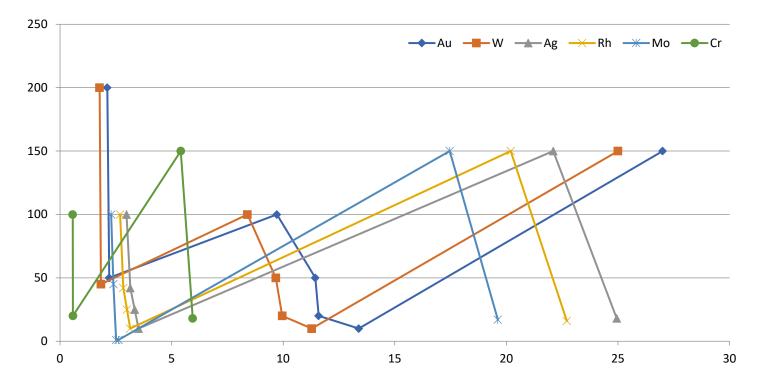
- Intensity is inversely proportional to the square of the distance from the source of that physical quantity.
- 100x higher flux than collimated system at the same distance from the source.



Supported Locally.



Potential of Different Tube Target





Auto Focus (Laser)

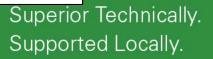
- Quickly and automatically focus on samples
- Ensures each sample is measured at the same working distance
- Minimizes error from different operators





Pattern Recognition

- Corrects position when the measurement location is off
- Automatically find next measurement location
- Minimize operator error
- Speed of process Throughput





XYZ Programming

- Read parts in random, linear, or grid patterns.
 Just pick a start & end point.
- Datum reference points can compensate for up to <u>+</u>10° sample rotation

Superior Technically.

Supported Locally.

Allows for fast measurement of multiple pad
 locations



Automatic Data Export

- Automatically export data to XRF PC
 - Export at end of each test
 - Export data linked with unique identifiers (i.e barcode, part number)
- Fully customizable data export
 - Export raw data
 - Automatically generate reports

